

Supplementary Information

for

Ligand Assisted Growth of Perovskite Single Crystals with Low Defect Density

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Supplementary Table 1. Dark current drift and resistivity of the as-grown MAPbI_3 crystals with DPSI in Fig. S6 without any surface treatment.

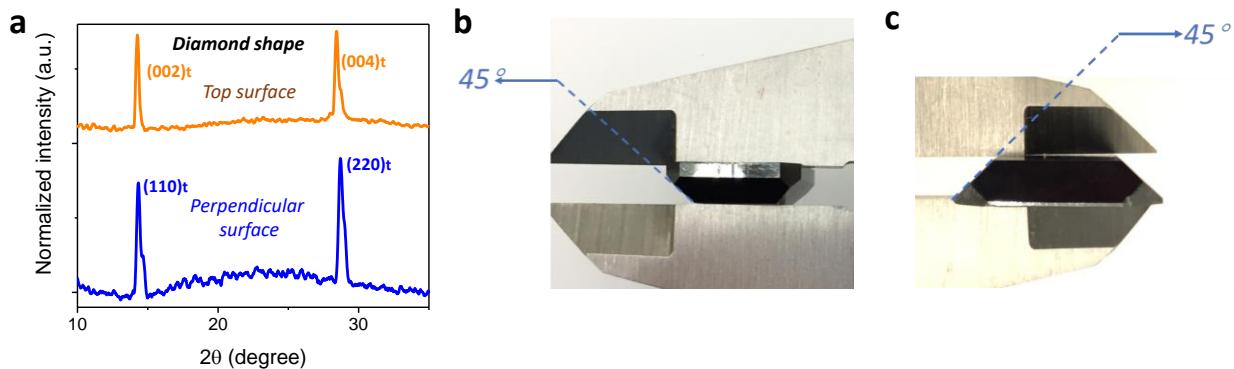
Electric field (V cm ⁻¹)	Dark current (nA cm ⁻²)	Resistivity (Ω cm)	Current drift (nA cm ⁻¹ v ⁻¹ s ⁻¹)
50	27.2	1.84×10^9	5.95×10^{-5}
125	48.8	2.56×10^9	2.45×10^{-5}
250	80	3.13×10^9	1.48×10^{-5}

Supplementary Table 2. Summary of the sensitivity and lowest detectable dose rate of different perovskite X-ray direct and indirect radiation detectors.

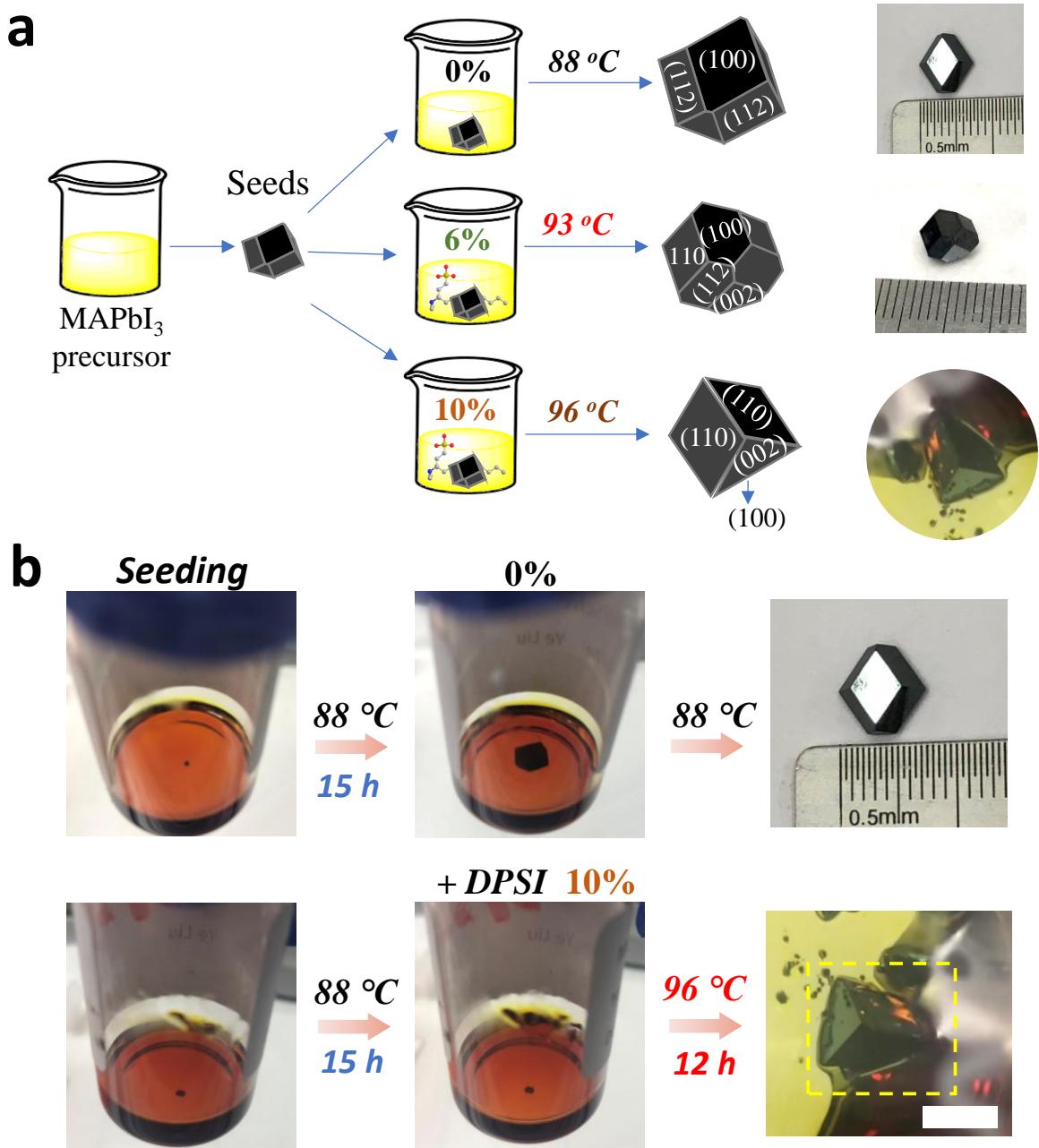
Indirect conversion (Scintillators)	Perovskite composition	X-ray energy (keV or kVp)	Sensitivity ($\mu\text{C Gy}^{-1}\text{air cm}^{-2}$)	Lowest detectable dose rate ($\mu\text{Gy air s}^{-1}$)	Dark current drift (nA cm ⁻¹ v ⁻¹ s ⁻¹)	References
Indirect conversion (Scintillators)	MAPbCl ₃ single crystal	50		0.1147		4
	Ru ₂ CuBr ₃	30		0.1215		5
	Rb ₃ Bi ₂ I ₉	50	159.7 (1 V bias)	0.00832	1.82×10^{-7}	6
	MAPbBr ₃ single crystal	8	80	0.5		1
	MAPbBr ₃ /Si integration	8	2.1×10^4	0.036	1.2×10^{-3}	3
	MAPbBr _x Cl _{3-x} single crystal	8	8.4×10^4	0.0076		2
	MAPbBr ₃ single crystal (oil growth)		184.6			7
	(NH ₄) ₃ Bi ₂ I ₉ -		8.2×10^3	0.055		8

Direct conversion (Radiation detectors)	2D single crystal					
	BiOBr passivated Cs ₂ AgBiBr ₆ wafer film	50	250 (0.5V μm ⁻¹)	0.0953	7.4×10 ⁻⁵	9
	Cs ₂ AgBiBr ₆ single crystal	30	105	0.0597		10
	MAPbI ₃ cuboid shape crystal		968.9			11
	(GMA)MAPbI ₃ single crystal	8	2.3×10 ⁴ (5V bias)	0.0169		12
	MAPbI ₃ sintered wafer	70	2.527 ×10 ³ (200V bias)		1.7×10 ⁻³	13
	MAPbI ₃ pressed sinter	40	1.22×10 ⁵ (10 V bias)	2.54		14
	Cs ₃ Bi ₂ I ₉ Single crystal	40	1.652×10 ³ (60 V bias)	0.130		15
	(F-PEA) ₂ PbI ₄ 2D single crystal	120	3.402×10 ³ (200V bias)	0.023	4.9×10 ⁻⁸	16
	MAPbI ₃ (printable film)	100	1.1×10 ⁴			17
	MAPbI ₃ (Cl) in membrane	60	8,696±228			18
		100	1.44×10 ⁴ (20V bias)			
	MAPbI ₃ thin single crystal (co-planar)	50	7.0×10 ⁵ (5V bias)	0.0015		19
		8	2.1×10 ⁵ (10V bias)	0.00234	6.58×10 ⁻⁶	

	MAPbI ₃ single crystal with ligand-assisted		2.8×10^5 (20V bias)		1.3×10^{-5}	This work
60		2.9×10 ⁶ (100V bias)	0.0057		4.7×10^{-5}	
100		6.51×10^5 (100V bias)				
120		1.04×10^6 (100V bias)				

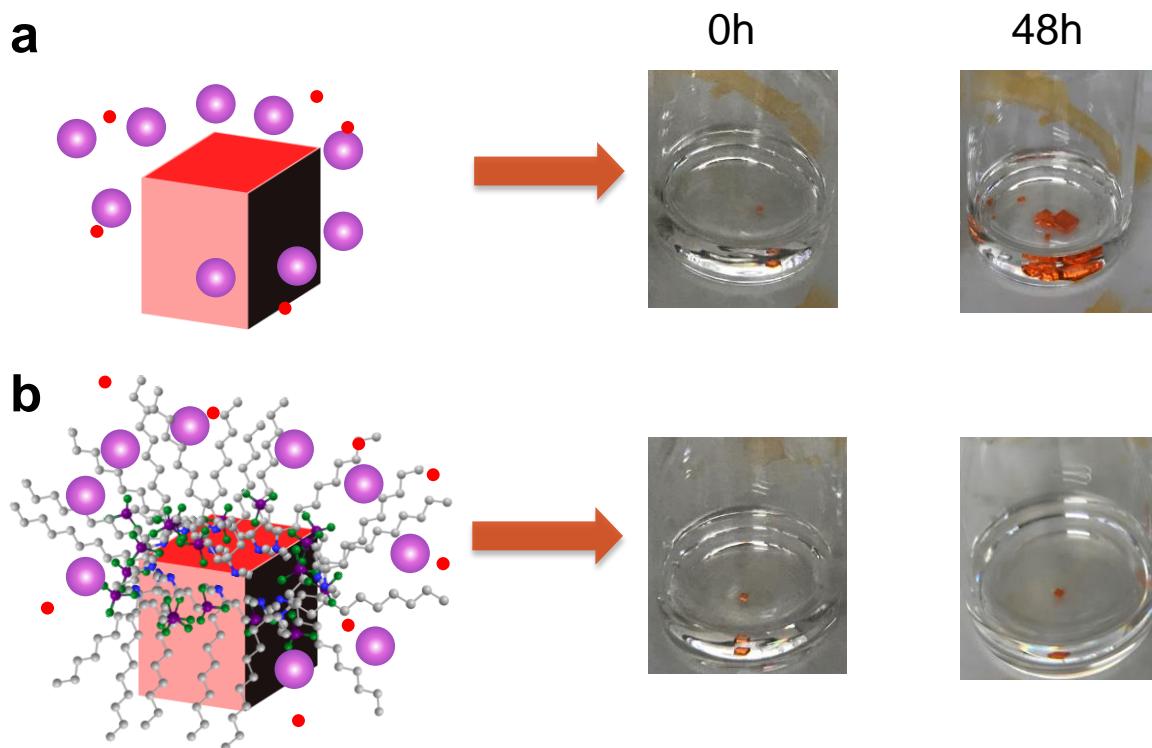


Supplementary Fig. 1. **a)** XRD pattern of different facets of the diamond-shaped crystal shown in Fig.1A. **b, c)** photos of the two crystals grown in 10% DPSI added, and the facet angles were measured.

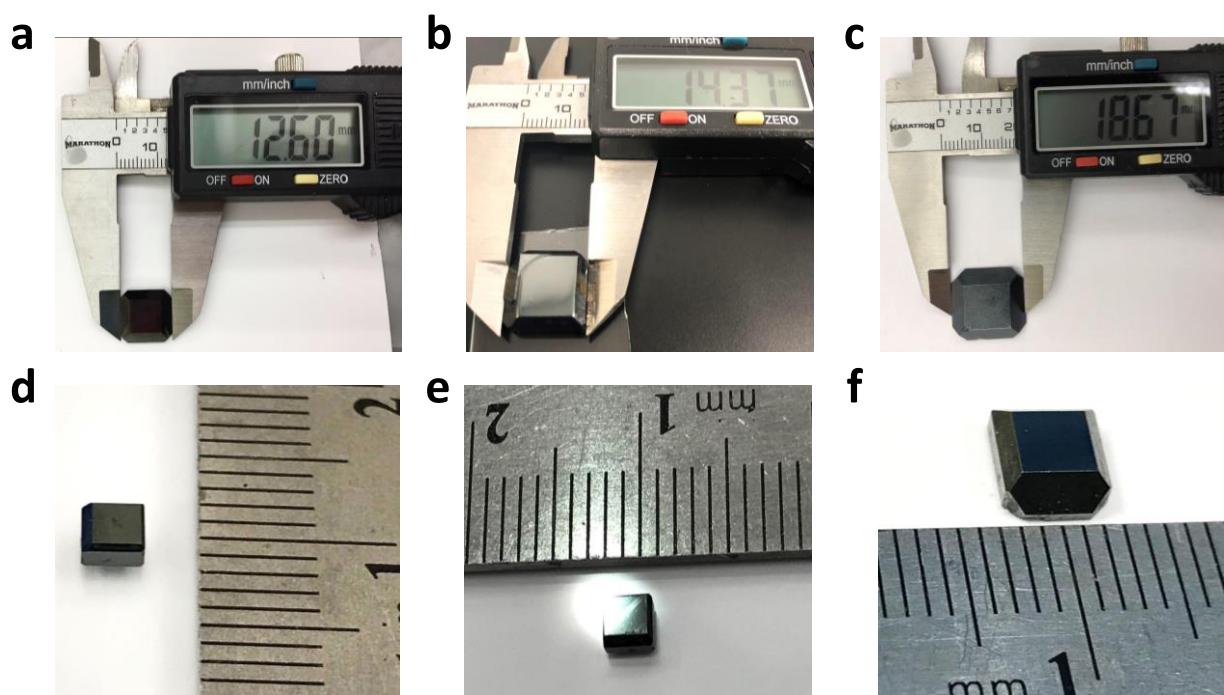


Supplementary Fig. 2. Crystal growth behavior with ligand regulation after seeding. **a)**

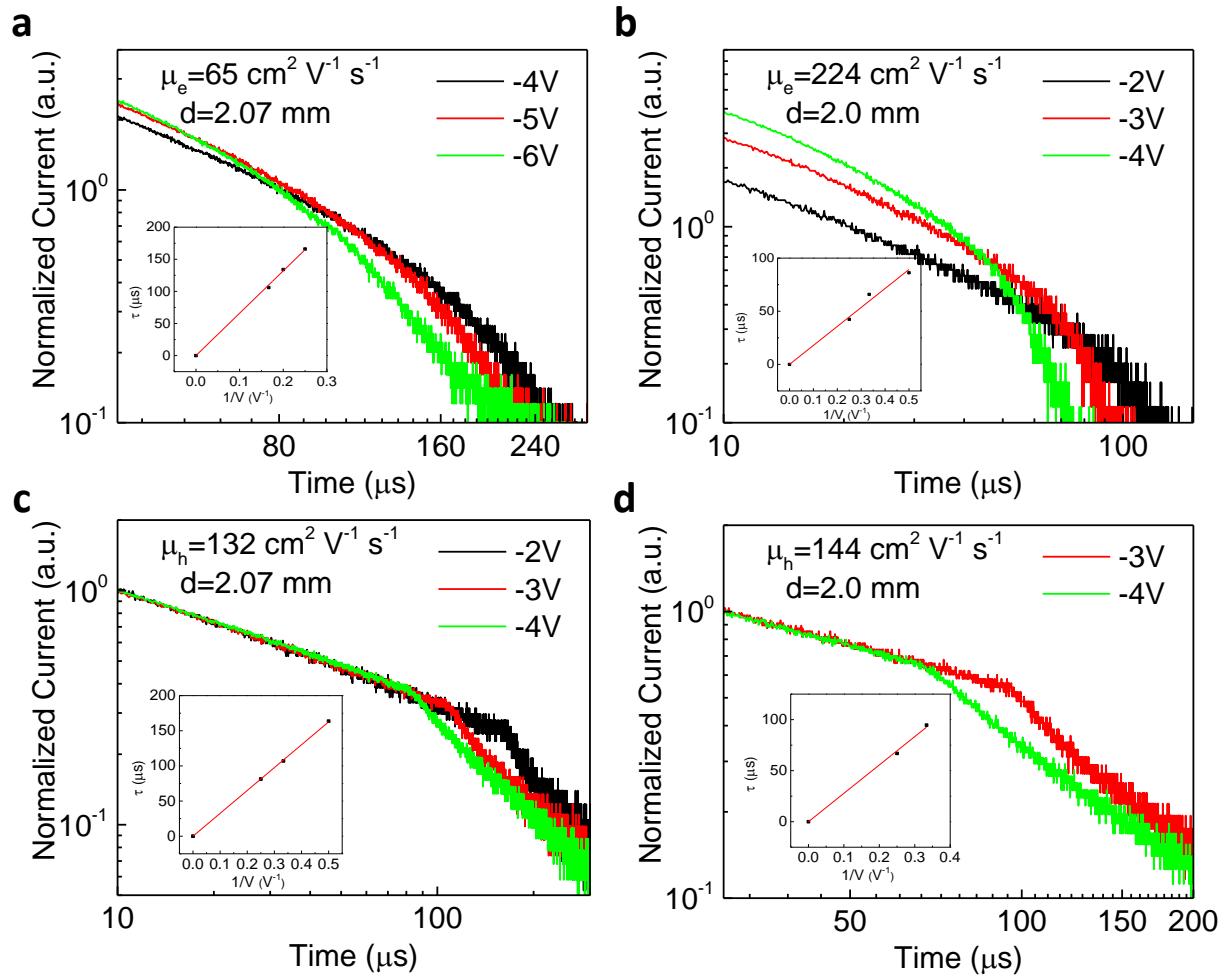
Scheme and photos of crystal growth process after seeding dodecahedral crystals (pristine MAPbI₃ crystal) in precursor solutions w/o and with DPSI. **b)** The crystal growth rate comparison of the crystals w/o and with DPSI at different temperature after seeding. The scale bar is 5 mm.



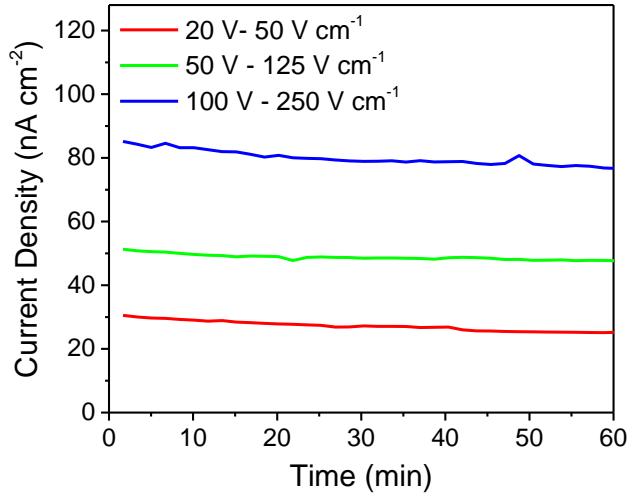
Supplementary Fig. 3. Crystal growth behavior of MAPbBr₃ single crystals with adding DPSI in precursor. a, b) Scheme and photograph of the crystals growth rate comparison w/o and with DPSI.



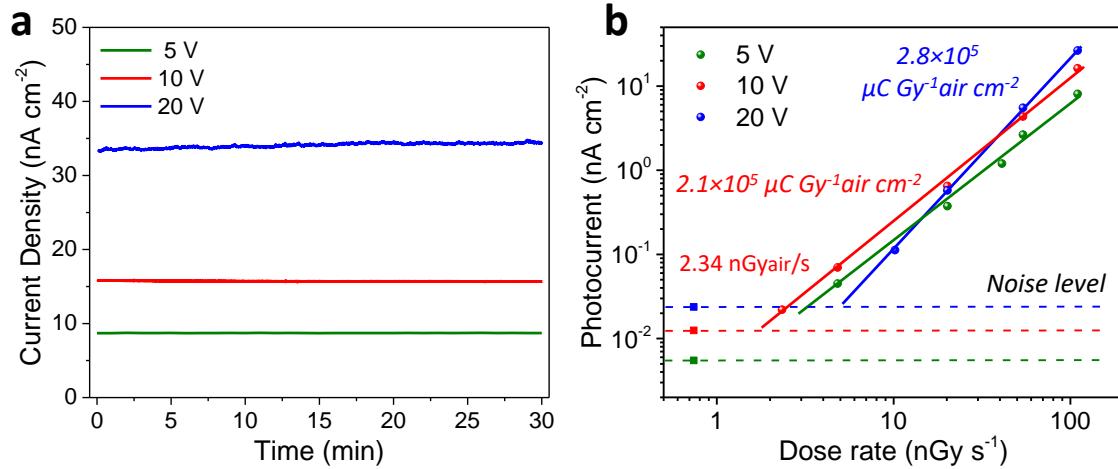
Supplementary Fig. 4. Photographs of MAPbI₃ single crystals grown with molar ratio of 10% DPSI in different dimensional sizes: a-c) some large crystals above 1 cm in length and d-f) some small crystals.



Supplementary Fig. 5. Crystal quality improvement of MAPbBr_3 single crystals with DPSI in precursor solution. Electron and hole carrier mobility of the crystals grown **a, b)** w/o and **c, d)** with DPSI, respectively.

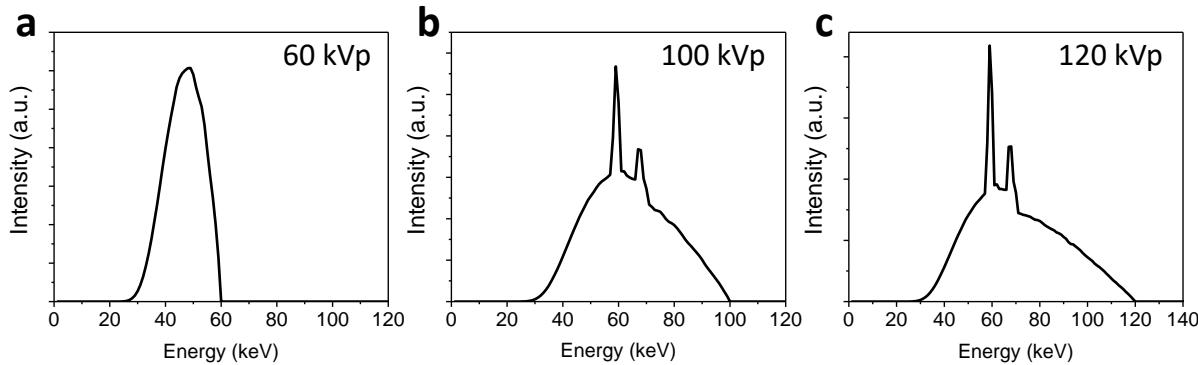


Supplementary Fig. 6. Dark current drift of a non-encapsulated device based on MAPbI_3 single crystal grown with DPSI under different applied electric field of 50 V cm^{-1} , 125 V cm^{-1} and 250 V cm^{-1} . The crystal thickness was 4 mm without any surface treatment before device fabrication, and the photograph of the crystal was shown in Supplementary Fig. 4c.



Supplementary Fig. 7. Performance of the X-ray detector under soft X-ray energy with energy of 8 keV. **a)** Dark current drift in air without encapsulation, and **b)** X-ray sensitivity measurement excited by 8 keV X-ray beam energy under bias of -5 V, -10 V and -20 V. The

crystal thickness was 3.7 mm, which is the same crystal in Fig. 4b and its photograph is shown in Supplementary Fig. 4a.



Supplementary Fig. 8. Simulated X-ray energy spectrum of the source by SPEKTR 3.0 with 21 mm Al filter at **a)** 60 kVp, **b)** 100 kVp and **c)** 120 kVp.

Supplementary References

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